

Notice of References Cited	Application/Control No. 10/817,205		Applicant(s)/Patent Under Reexamination CORNWELL ET AL.	
	Examiner SHEW-FEN LIN		Art Unit 2166	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,454,108	09-1995	Devarakonda et al.	718/104
*	C	US-5,596,754	01-1997	Lomet, David B.	710/200
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NON-PATENT DOCUMENTS

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	U	"Locking in DB2 for MVS/ESA Environment", August 1996, International Technical Support Organization, San Jose Center
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.